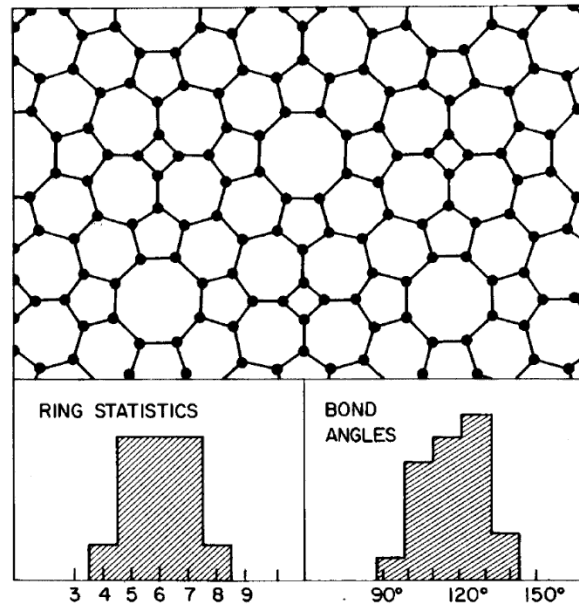


Band tails and conductivity in disordered materials

Disorder in amorphous silicon

- Waves with short wavelengths (high energy) feel short range order similar to the periodic crystal (four fold coordination of nearest neighbours)
- Waves with long wavelengths (low energy) are disturbed by lack of long range order (localization)

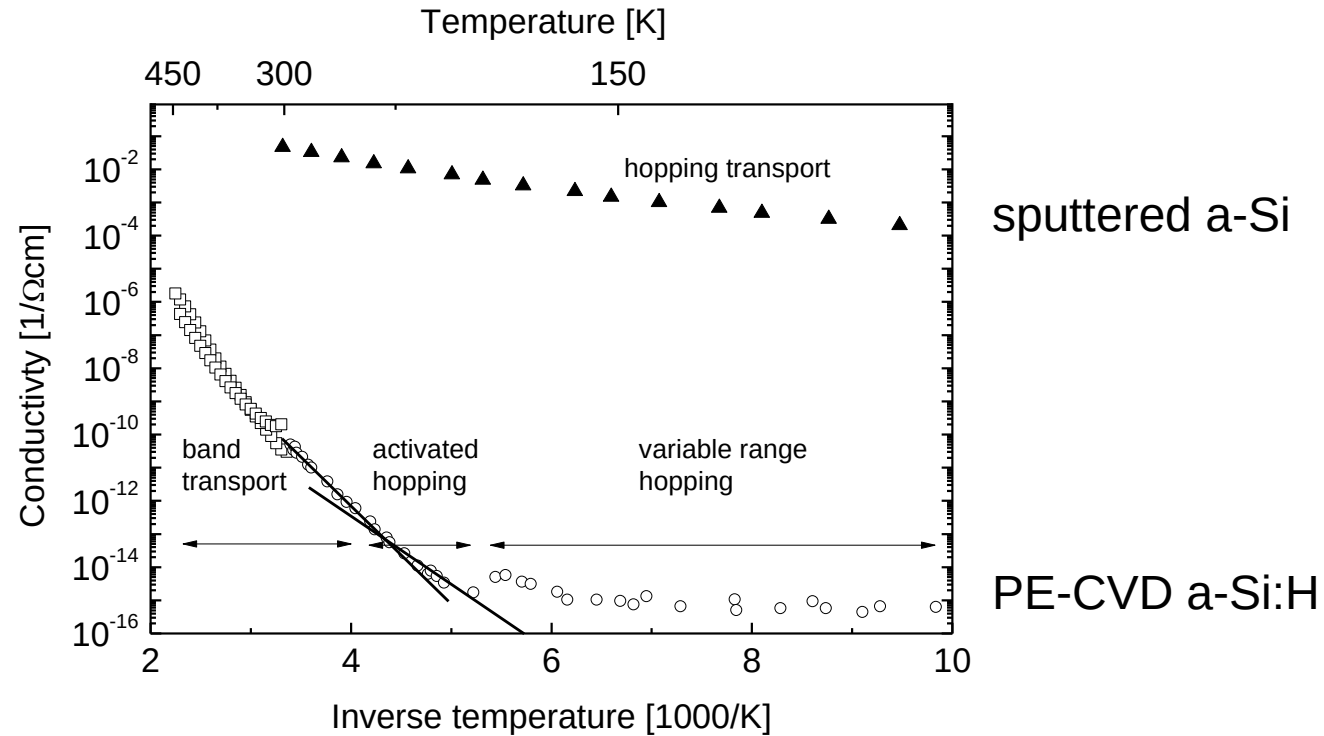


Consequence in Si:

- similar high energy interactions
- low energy interactions will be modified (properties close to **band edges!**)

DC-conductivity in a-Si and a-Si:H

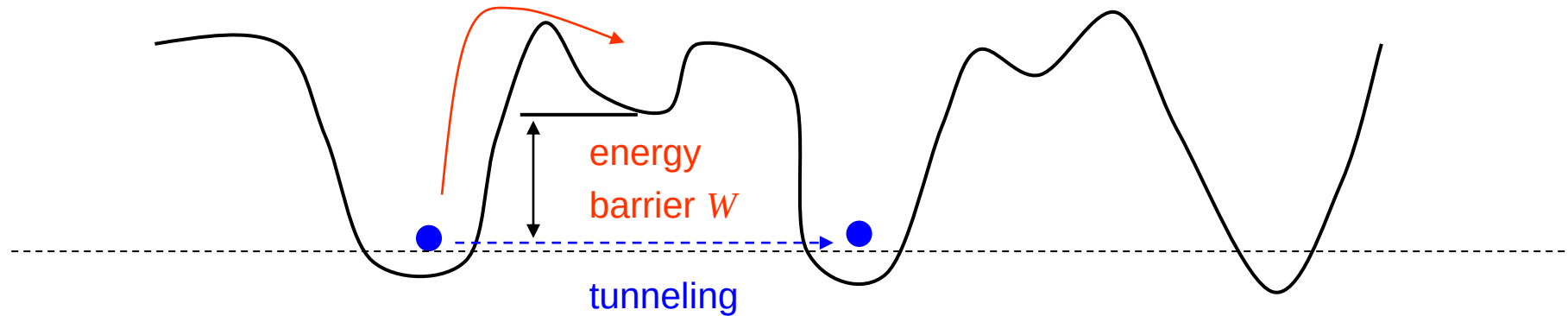
Temperature dependence of the conductivity



Arrhenius plot: slope $\Rightarrow$ activation energy of transport process

Hopping conductivity

If $g(E)$ is high within the gap (sputtered material):
hopping between localized states around E_F :



nearest neighbour hopping
(below room temperature):

$$\sigma(T) = \sigma_0 e^{-W/kT}, \quad \sigma_0 = 2e^2 r^2 v_{ph} g(E_F) e^{-2\alpha_L r}$$

variable range hopping
(very low temperature):

$$\sigma(T) = \sigma_0 e^{-B/T^{1/4}}, \quad \sigma_0 = e^2 r^2 v_{ph} g(E_F)$$

Extended state conductivity

For high T and low $g(E)$ within the gap (PECVD-material): extended state conduction (conduction by delocalized states around E_C or E_V):

$$\sigma(T) = en\mu = e \int_0^{\infty} g(E) f_{FD}(E, T) \mu(E) dE$$

$$\approx e\mu_0 \int_0^{\infty} g(E) f_{MB}(E, T) dE \approx \underbrace{e\mu_0 g(E_0) kT}_{\sigma_0} e^{-(E_0 - E_F)/kT}$$

$(E_0 - E_F) \approx 0.6 - 0.8$ eV, activated transport similar to crystalline semiconductors

Activation energy

Attention: E_0 in the conductivity is close to, but not equal to, the band gap

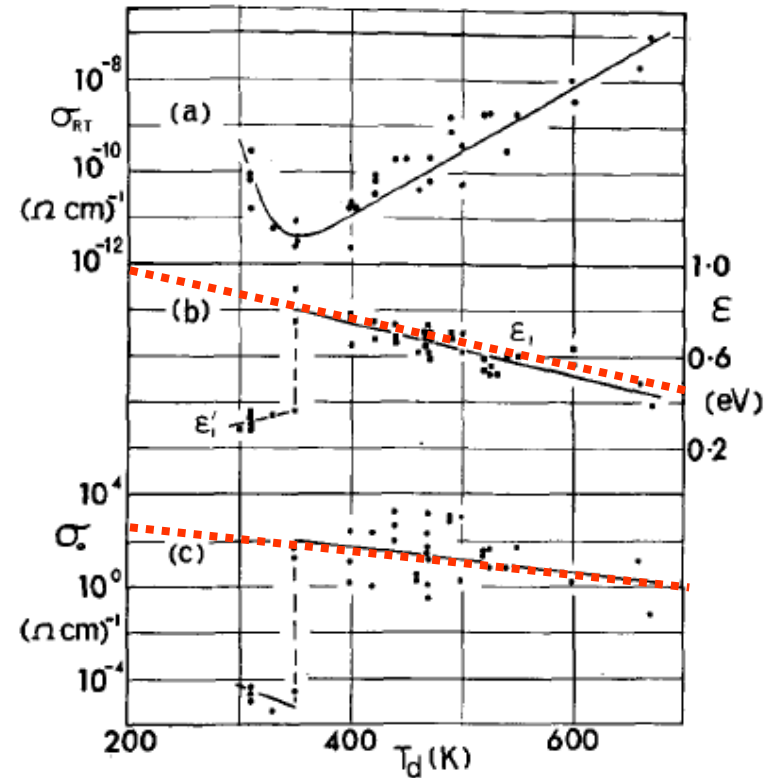
Spear's data suggest a relation between the activation energy $E_a = (E_0 - E_F)$ and the pre-factor σ_0 (statistical shift)

$$\sigma_0 = \sigma_{00} e^{(E_0 - E_F) / E_{MN}}$$

Meyer-Neldel relation,

$$E_{MN} \approx 50 \text{ meV}$$

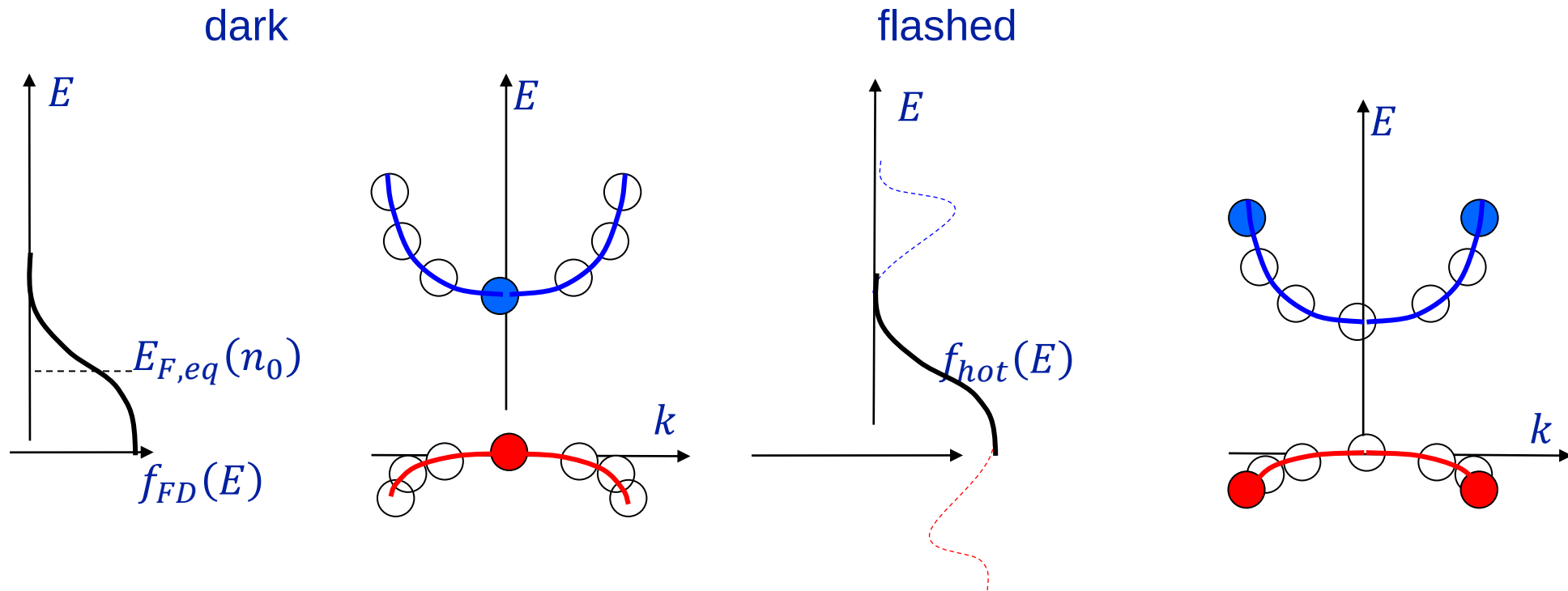
Underlying reason :
presence of band tails!



Drift mobility

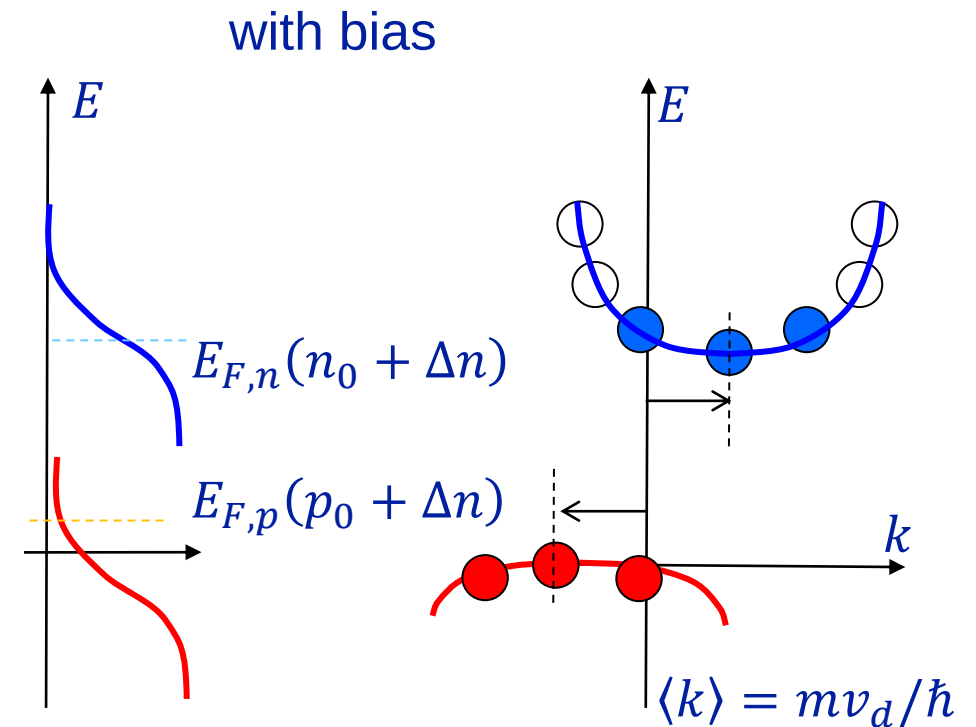
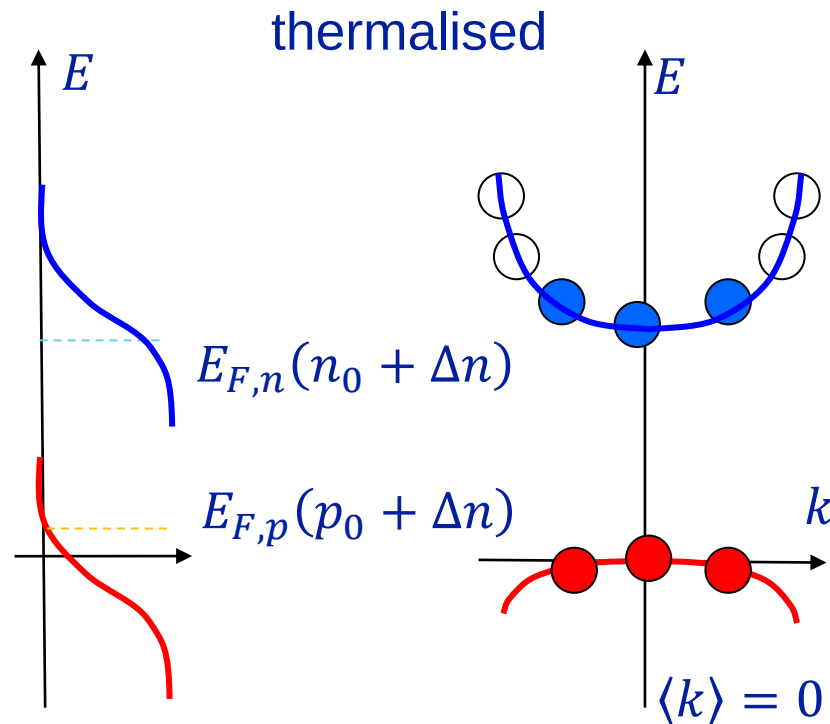
Equilibrium mobility too low for Hall effect => Use non-eq. drift mobility

- excite with a short pulse of (blue) light
- injection of hot carrier distribution Δn (and Δp) close to surface

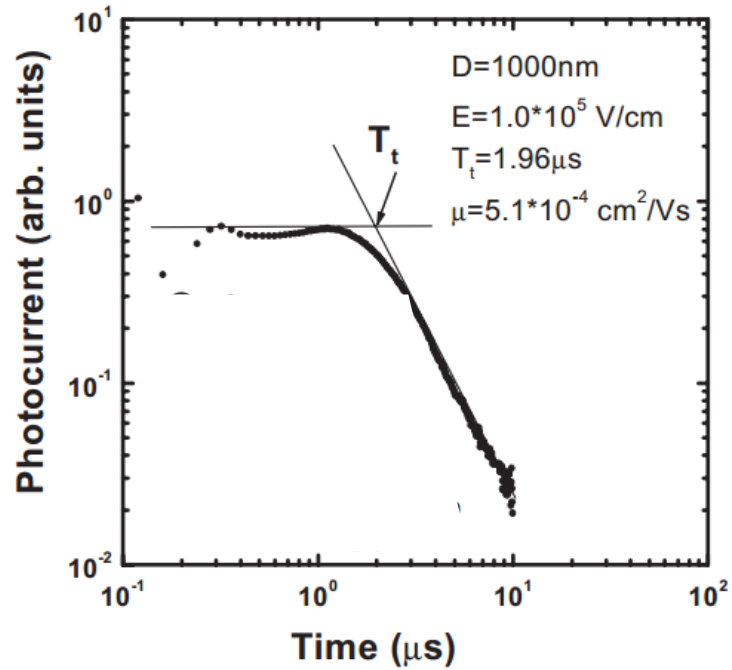
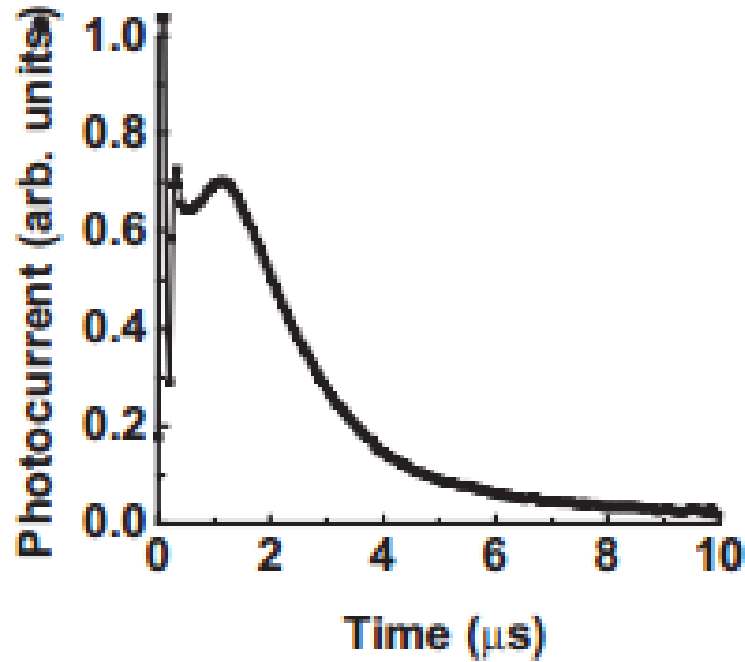


Drift mobility

- after thermalisation ($\sim$ ps) $\Rightarrow$ two quasi eq. distributions with two QFLs
- apply bias voltage V across thickness d of the film
- Drift velocity $v_d = \mu E$, measure transit time t_T to other side; $v_d = d/t_T$



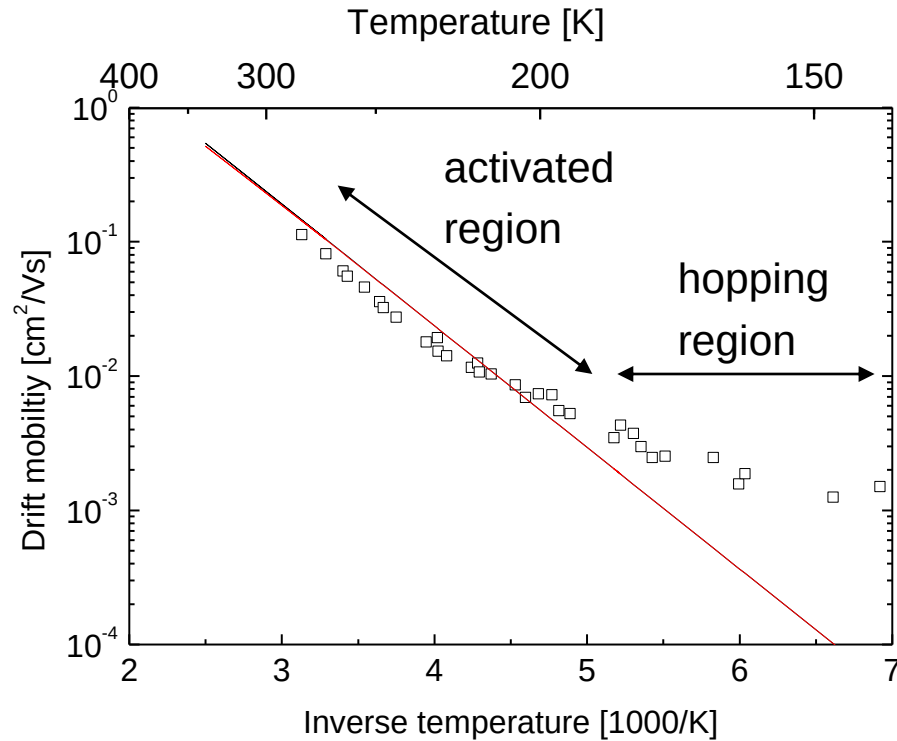
Example: drift in organic semiconductor



Drift mobility:

$$\mu_D = \frac{v}{E} = \frac{D}{t_T E}$$

Temperature dependence of drift mobility



Arrhenius plot:

Linear region around RT: $E_{\text{act}} \approx 0.2 \text{ eV}$

Note: non-equilibrium process,
different from Hall mobility

LeComber, JNCS 11, p219 (1972)

Thermally activated drift mobility: trap level

Assumption: only free carriers in bands can contribute to transport

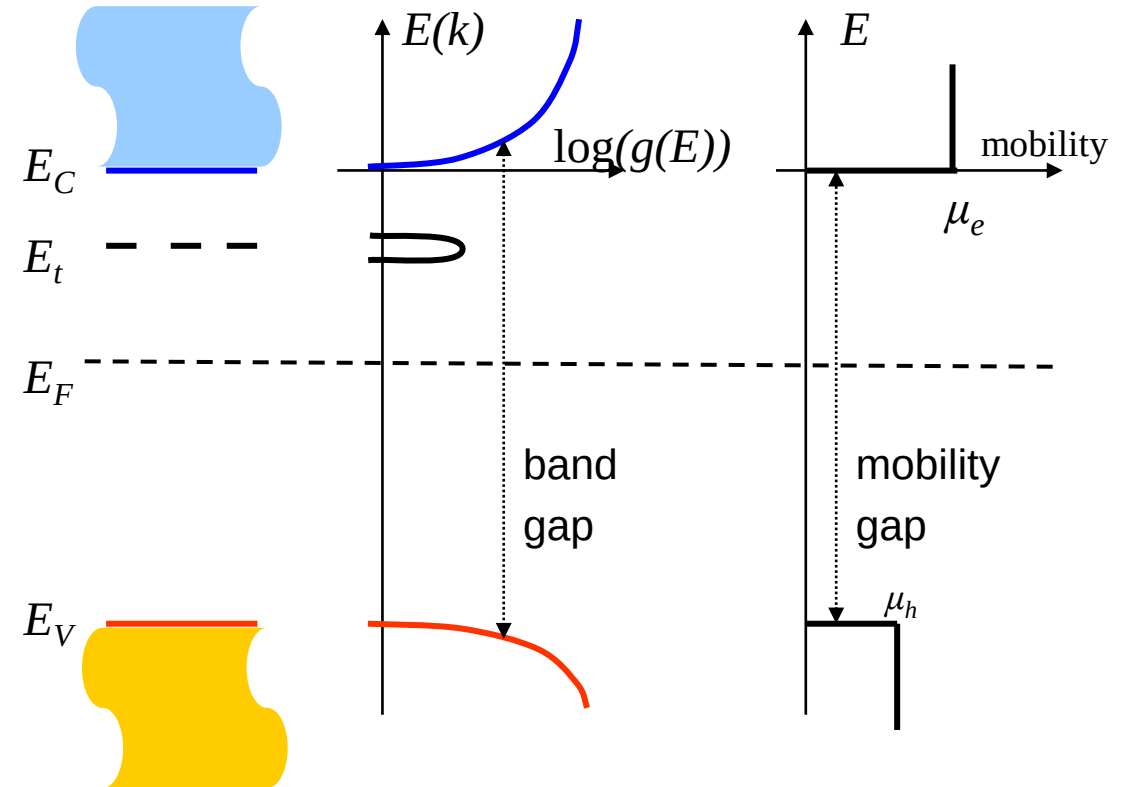
$$\mu_d = \mu_0 \frac{n_{\text{free}}}{n_{\text{total}}} = \mu_0 \frac{n_{\text{free}}}{n_{\text{trapped}} + n_{\text{free}}}$$

Occupancy of CB (at $E = 0$),
taking into account N_t trap levels:

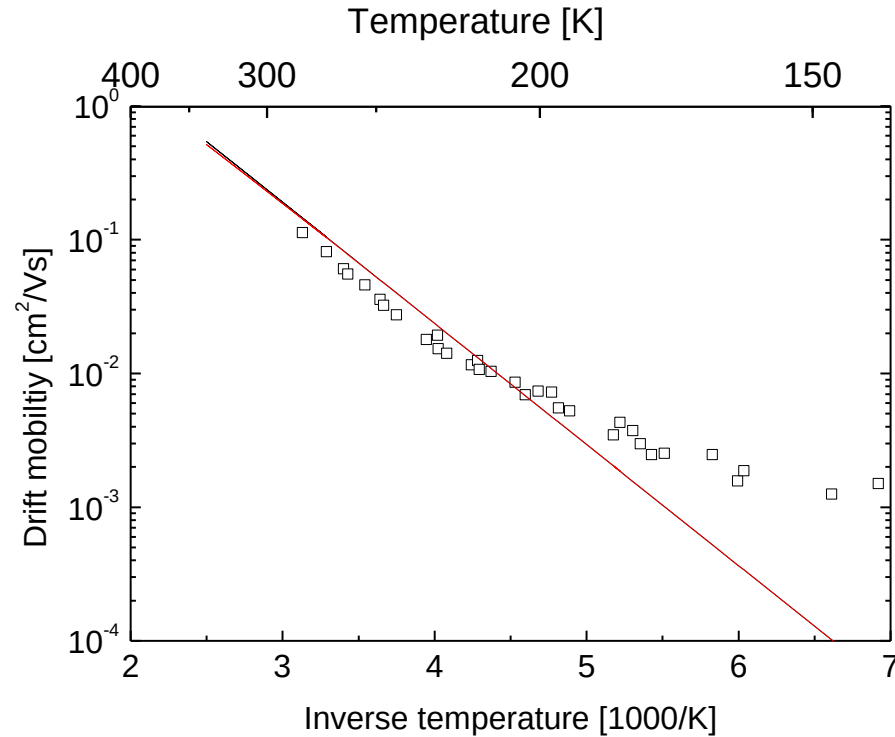
$$Q = \frac{N_c kT e^{-\frac{0}{kT}}}{N_c kT e^{-\frac{0}{kT}} + N_t e^{-\frac{-E_t}{kT}}}$$

$$\mu_d = \mu_0 \frac{N_c kT}{N_c kT + N_t e^{\frac{E_t}{kT}}}$$

Model assumes a mobility gap (sharp change close to band edge)



Drift mobility (non-equilibrium)



Model:

$$\mu_D = \mu_0 \frac{N_c kT}{N_c kT + n_t e^{E_t/kT}}$$

Boltzmann-like approximation

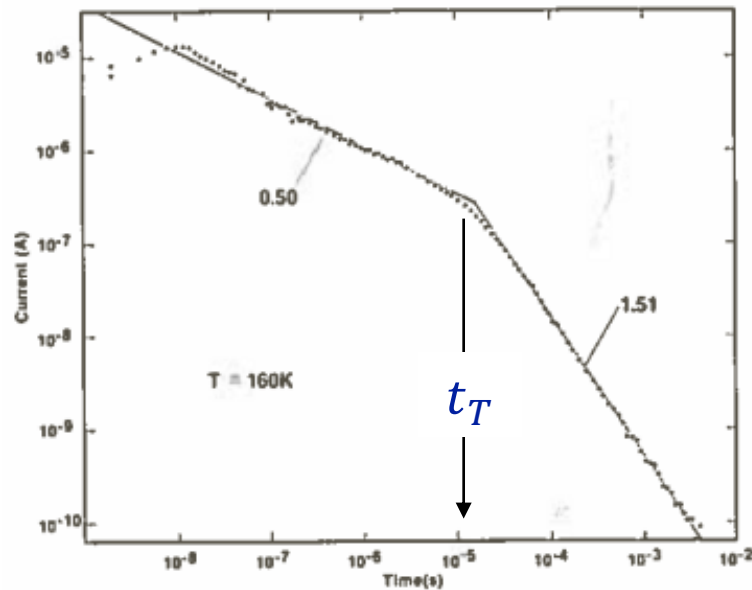
$$\mu_D \approx \mu_0 \frac{N_c kT}{n_t} \cdot e^{-E_t/kT}$$

E_t approximately 0.2 eV, approximation makes little difference in temperature range of interest

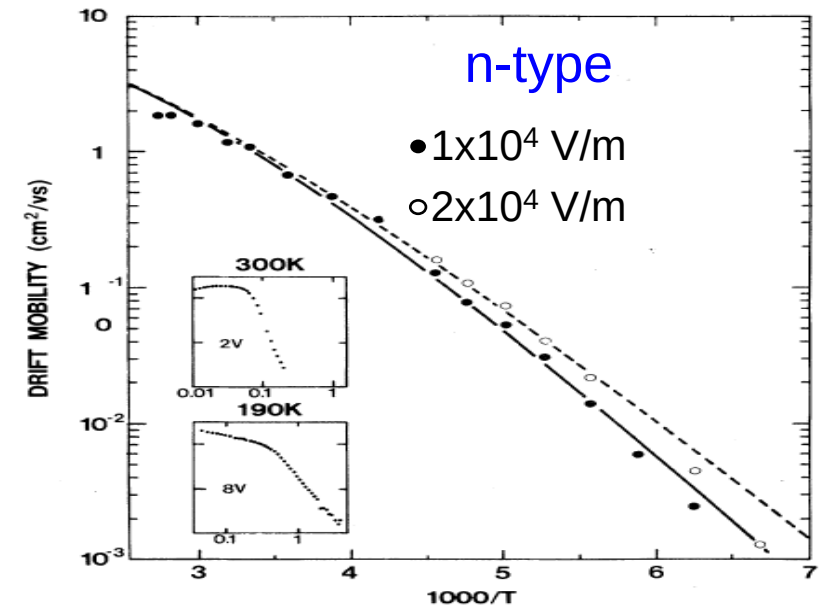
Second thoughts about drift experiments

Pulse shape not rectangular
Two decay regimes

measured in a-Si(H)



Mobility value depends on field
(higher mobility for faster sweep)



Improved model: multiple trapping conduction

Assumptions:

Exponential distribution of states

$$N_t(E) = N_C e^{E/kT_0}$$

Residence time depends on trap depth because of thermal release

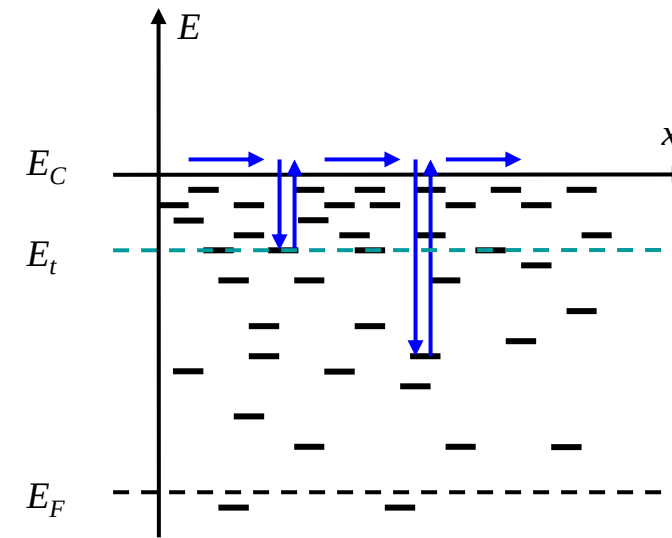
$$t = \nu^{-1} e^{E_t/kT}$$

Trap occupation: equilibrium between trapping and thermal release

=> maximum density of trapped carriers at an energy E_t below E_C

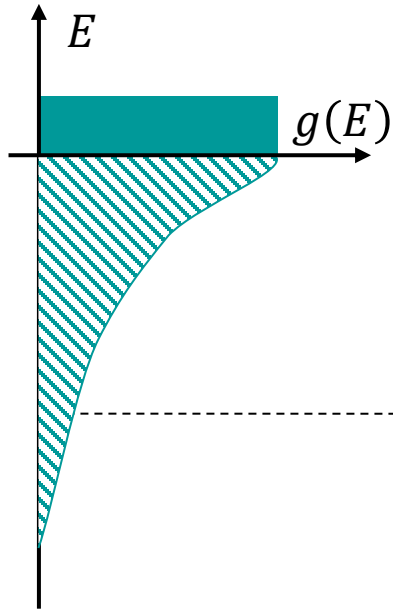
E_t depends on

- temperature (thermal activation)
- time (release from deep states can happen, but takes longer)

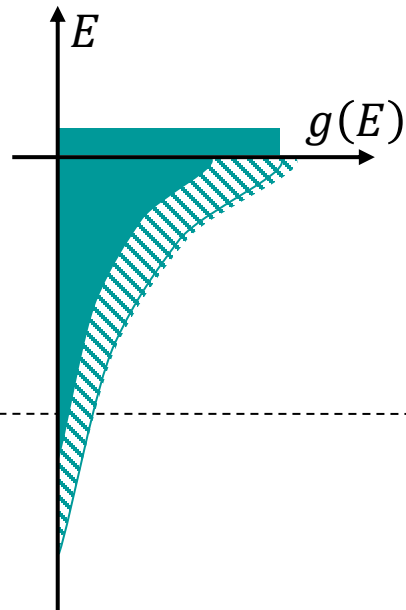


Time evolution of trapping statistics

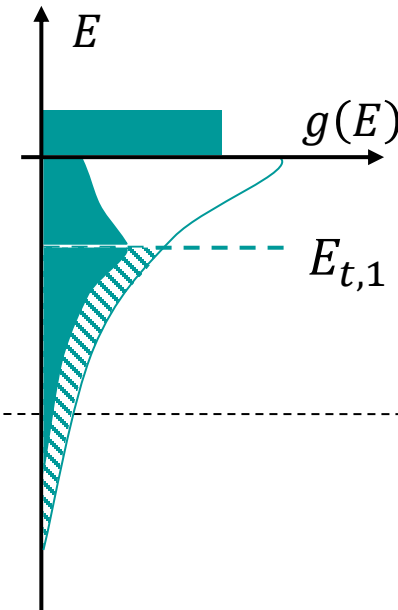
$$t = \nu^{-1} e^{E_t/kT} \quad \Leftrightarrow \quad E_t(t) = -kT \cdot \ln(\nu t)$$



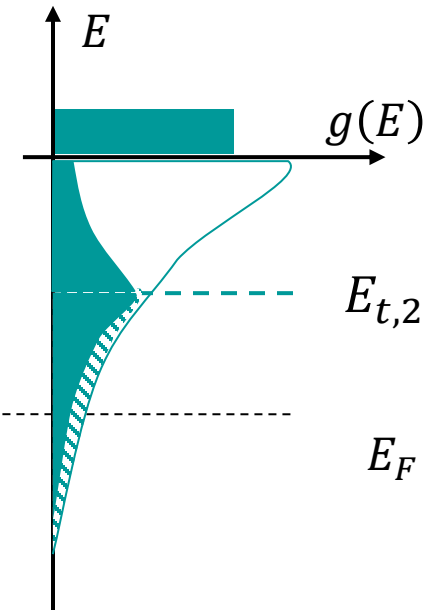
Excitation
into
CB



First trapping event:
a share of σ (cross
section) gets filled



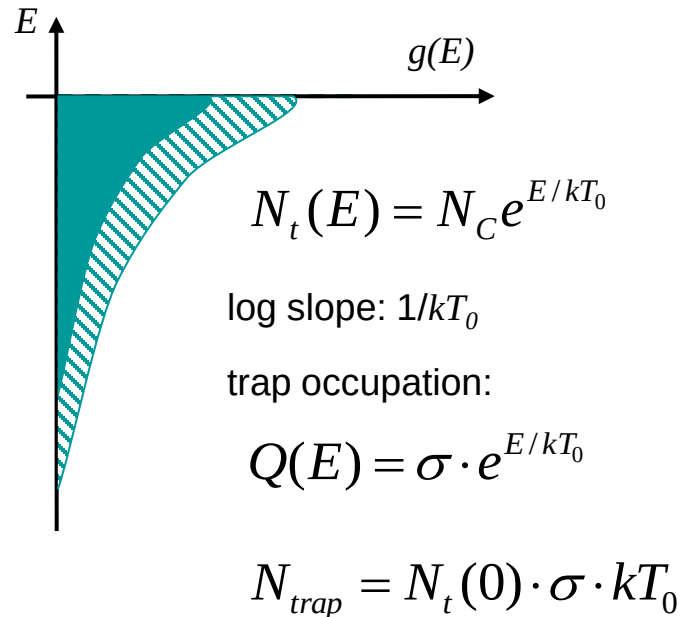
Thermal excitation
of upper part (and
extraction)



The most probable trap
energy E_t sinks deeper
into the band tail

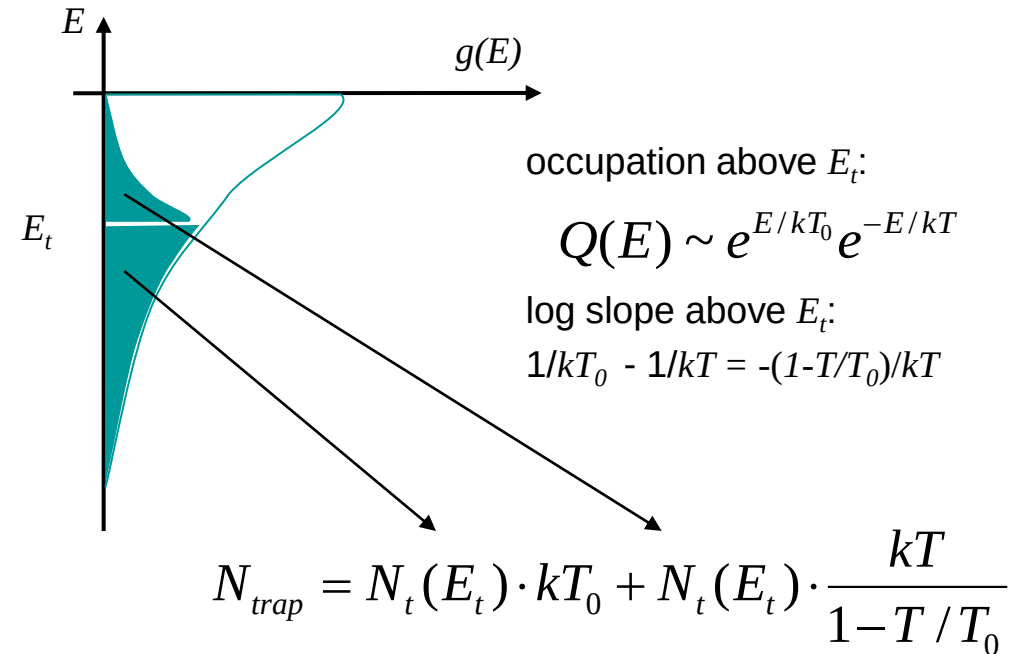
Effective value for trap density

first trapping event



Quasi-equilibrium at later time:

- upper part: thermal excitation into conduction band
- lower part: complete trapping



Drift mobility with trapping into band tail

Put most probable level N_t into occupation statistics of single trap level

$$\mu_D = \mu_0 \frac{N_c kT}{N_c kT + N_t(E_t) \cdot \left(kT + \frac{kT}{(1 - T/T_0)} \right) \cdot e^{\frac{E_t}{kT}}}$$

Use band tail density $N_t(E) = N_c e^{E/kT_0}$

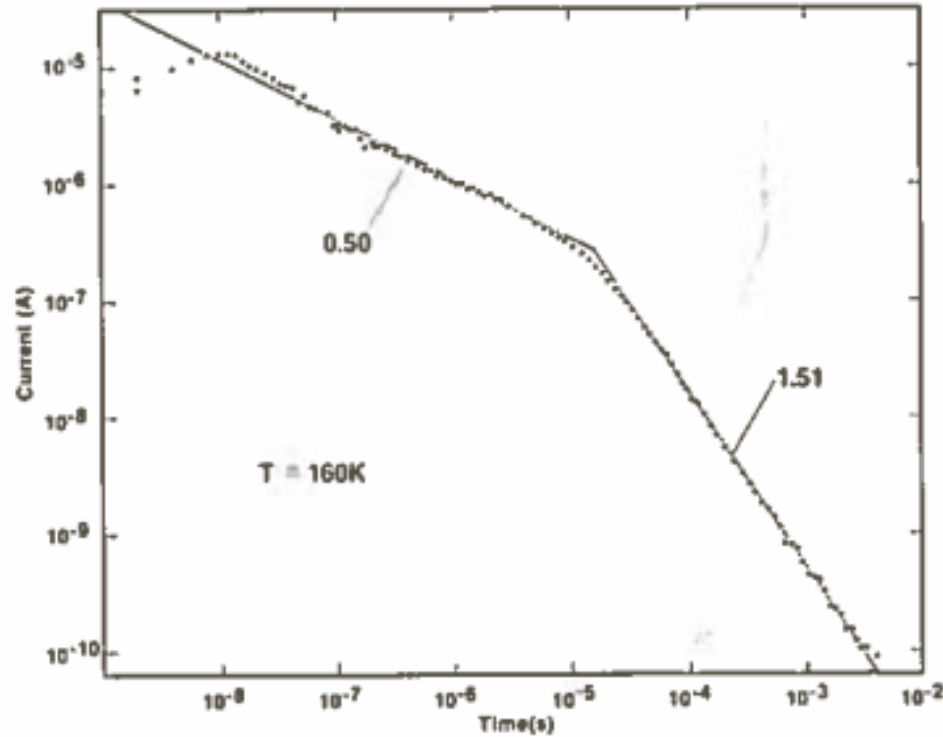
and “sinking” trap level $E_t(t) = -kT \ln \nu t$

$$\mu_D = \mu_0 \frac{1}{1 + (\nu t)^{(1-\alpha)} (T_0/T + 1/(1 - T/T_0))}$$

$$\mu_D \approx \mu_0 \cdot \alpha(1-\alpha) \cdot (\nu t)^{-(1-\alpha)}$$

Time dependent mobility ($\alpha = T/T_0$), result depends on measurement time!

Cross-check with measurement



Initial phase: transport with trapping from CB into sinking level (Tiedje)

$$\mu_D \approx \mu_0 \cdot \alpha(1-\alpha) \cdot (vt)^{-(1-\alpha)}$$

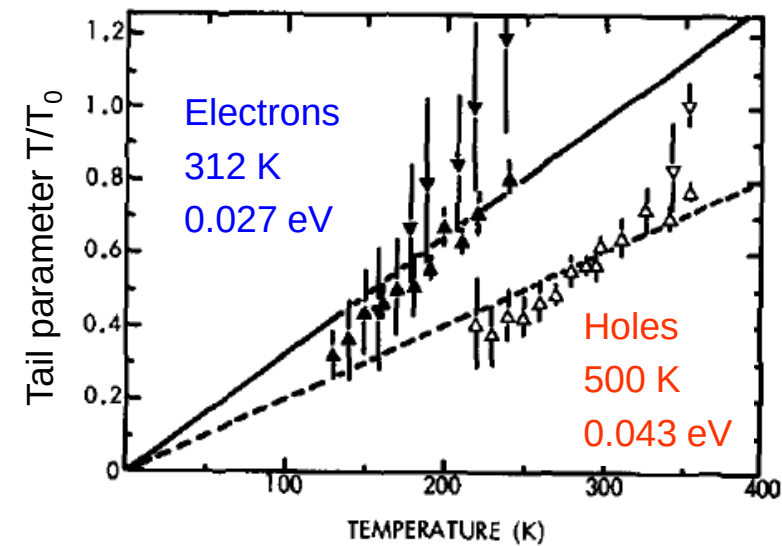
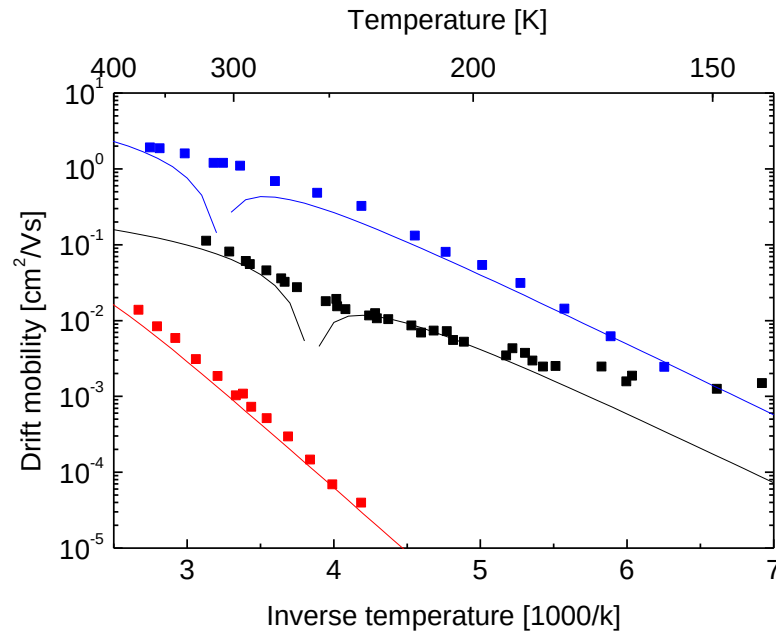
Later phase: hopping with trapping and delayed release (w/o derivation)

$$\mu_D \sim (vt)^{-(1+\alpha)}$$

Here: $\alpha = 0.5$, $T_0 \approx 320 K$

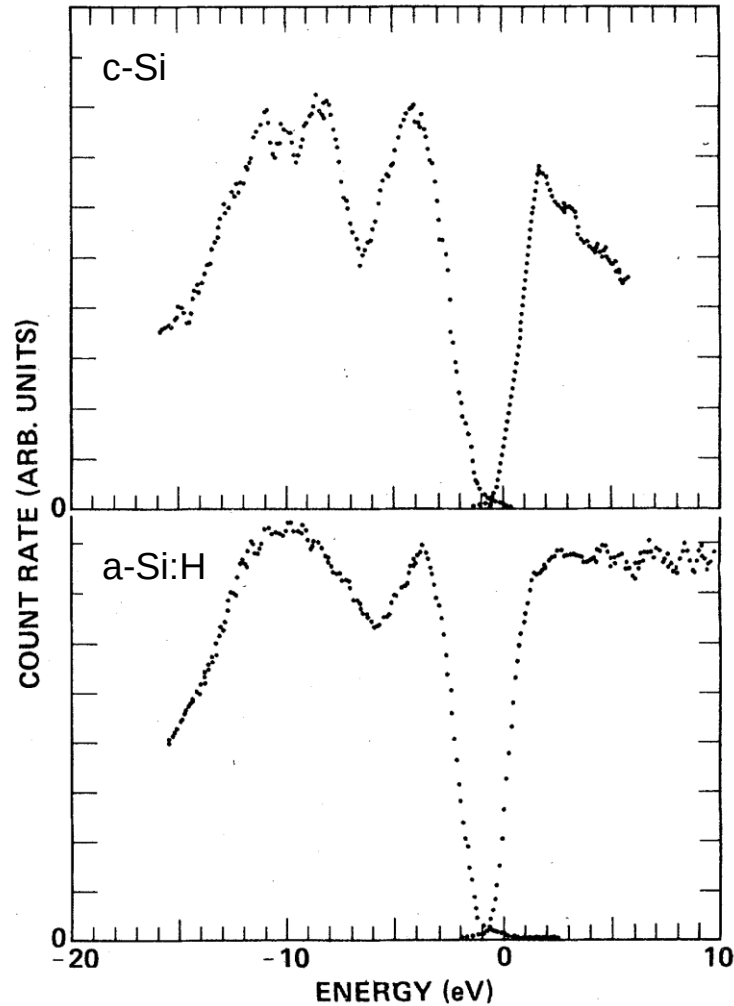
Band tail slope from drift mobility

Drift mobility shows transition between dispersive (low T) and non-dispersive transport (high T); transition at T_0



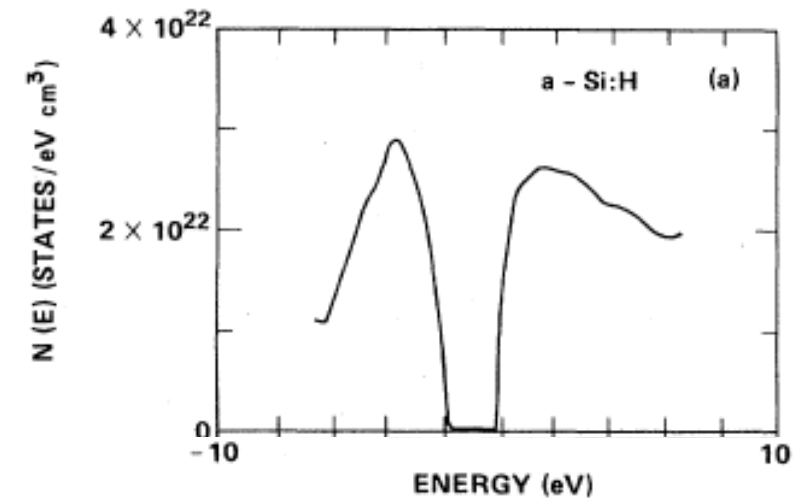
The detailed time- and temperature dependence of the signal dispersion yields the band tail slopes

XPS – direct measurement of bands tails

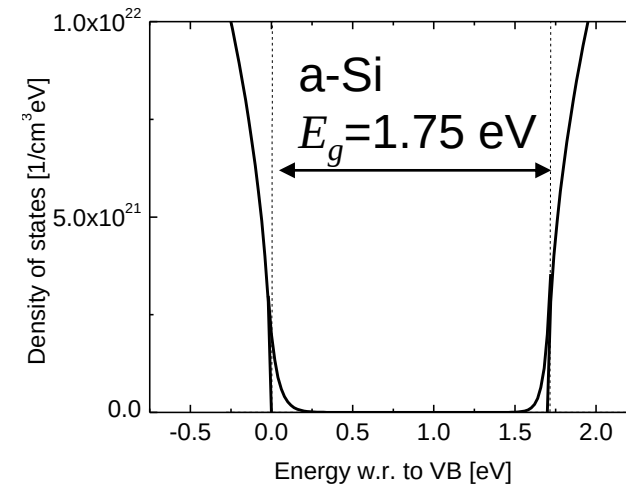
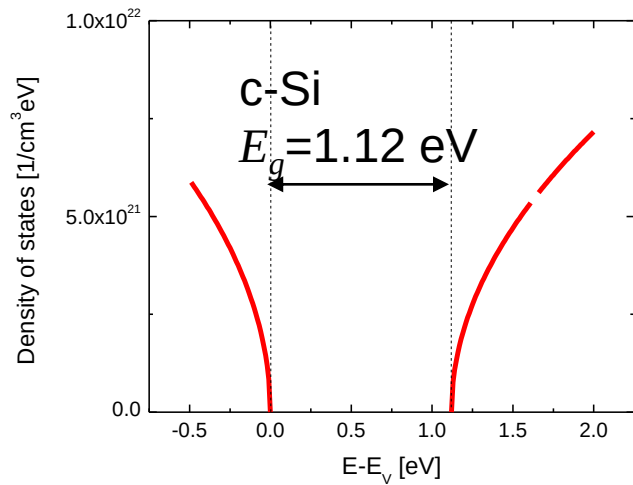
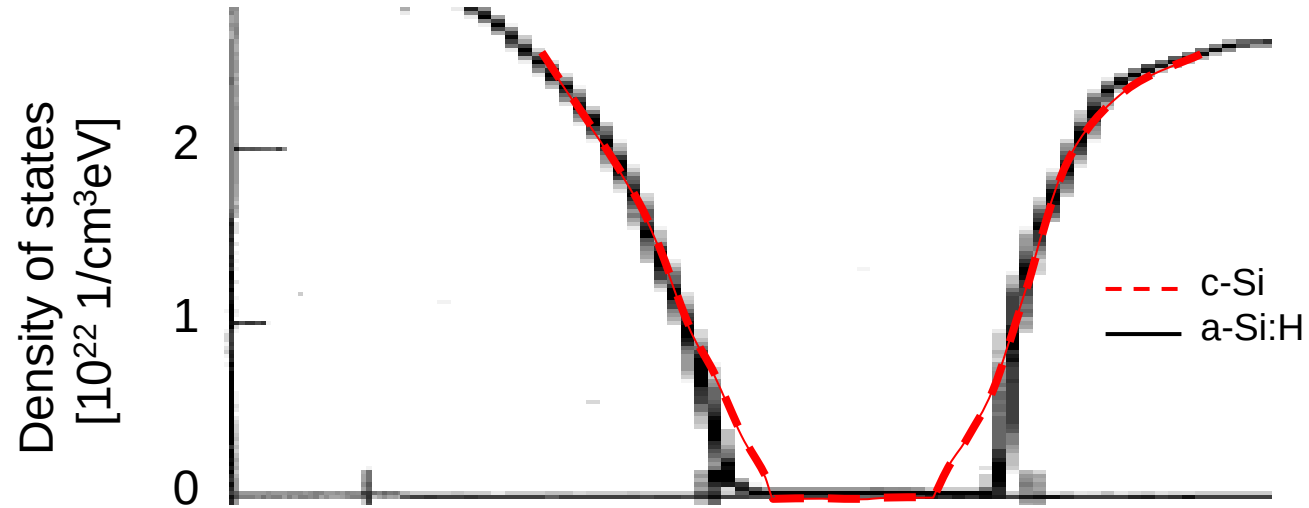


X-ray photoelectron spectroscopy (XPS)
excite e^- from filled states (VB)
inverse XPS: use light to pump electrons
into empty states (CB), excite from there

Determine density of states (DOS) for a-Si:H

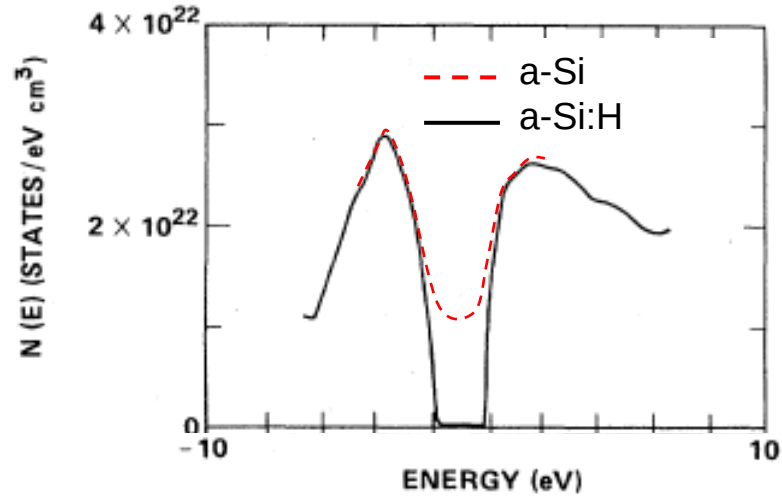


Detail: band edges of c-Si and a-Si

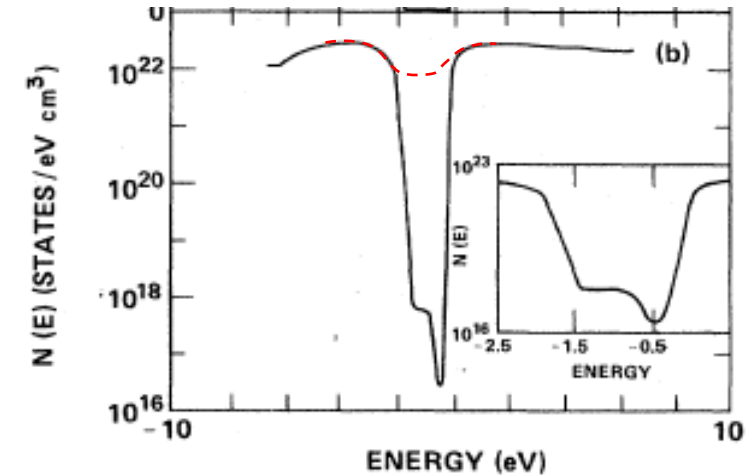


High resolution XPS

lin. scale



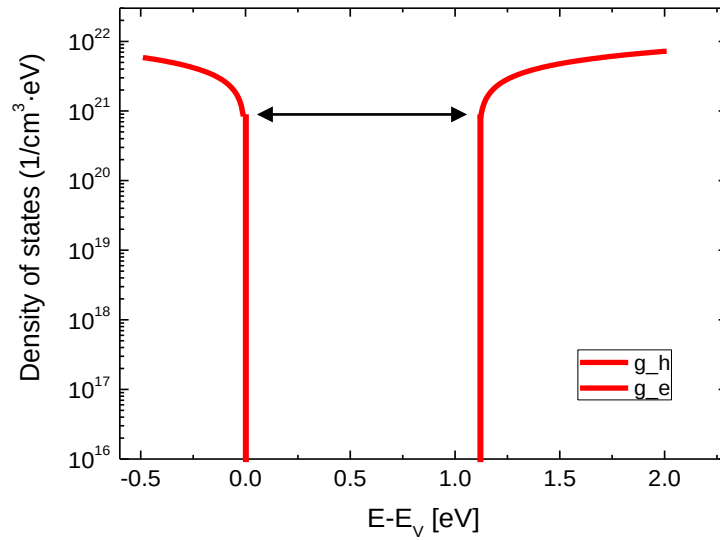
log. scale



Detailed band edge structure reveals band tails
(already suggested earlier on the basis of charge transport measurements)

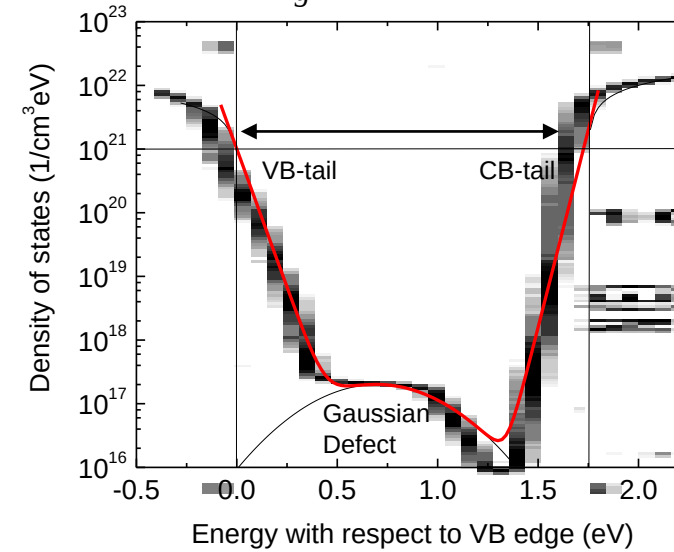
Detail of band edges

c-Si
 $E_g = 1.12$ eV



Sharp band edges, no gap states

a-Si:H
 $E_g \approx 1.75$ eV

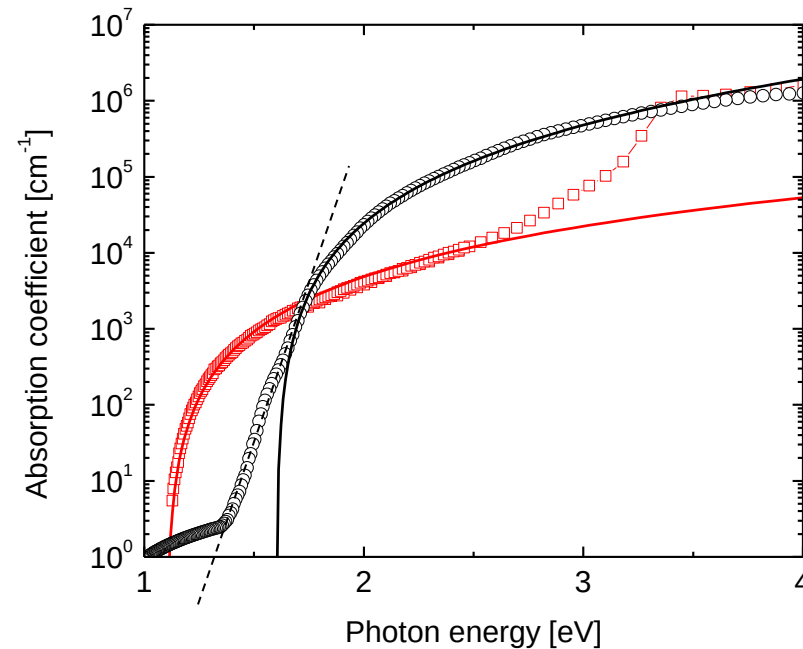


Band tails, mid-gap states

Optical signature of band tails

High energy > 3.5 eV: similar to direct transition in c-Si

Band edge region $1.8 \text{ eV} < E < 3.5 \text{ eV}$: non-direct gap, disorder



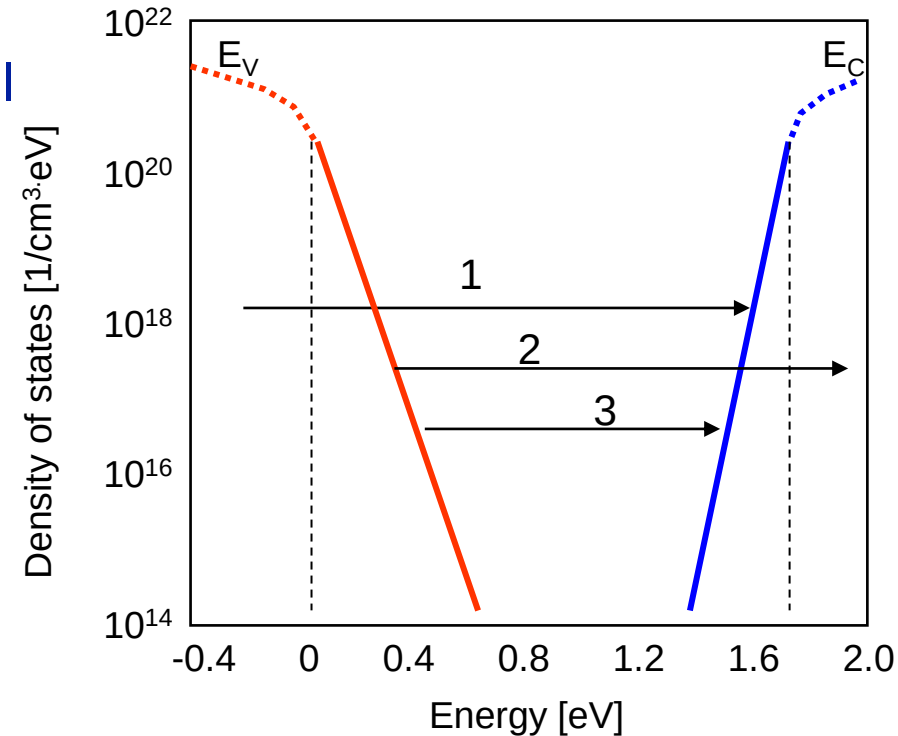
Band tail region $1.4 \text{ eV} < E < 1.7 \text{ eV}$: absorption due to exponential tail

Low energy $< 1.3 \text{ eV}$: defect absorption (see defect lecture)

Band tail absorption

Absorption processes:

1. VB to CB tail
2. VB tail to CB
3. VB tail to CB tail



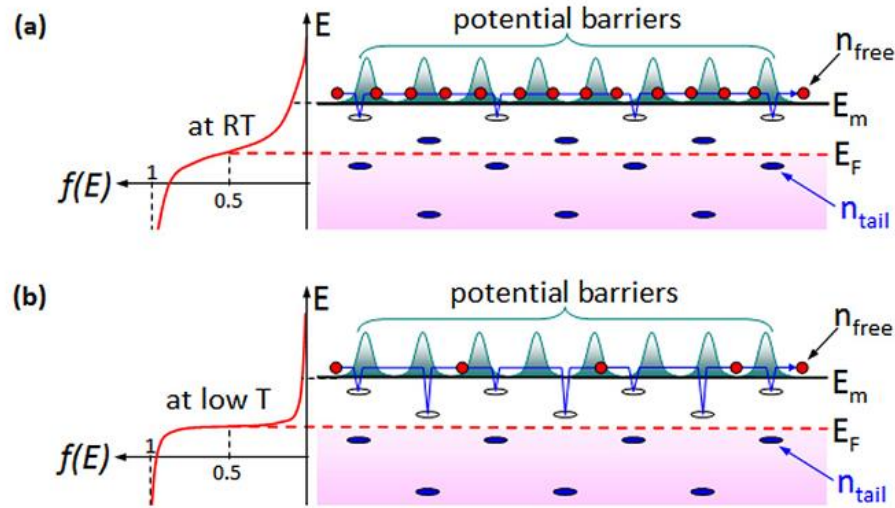
$$\begin{aligned}E_C &= 0.027 \text{ eV} \\E_V &= 0.043 \text{ eV} \\E_U &= 0.045 \text{ eV}\end{aligned}$$

=> Slope of Urbach absorption is dominated by valence band

Band tails

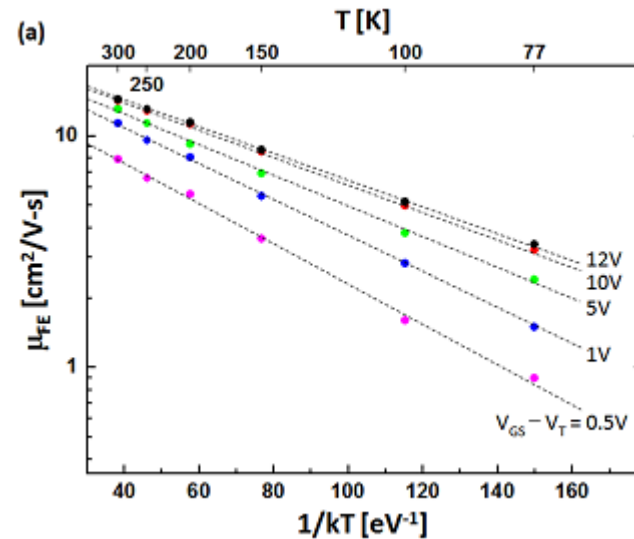
- band tails are a direct consequence of disorder
- several observations confirm their presence
 - dispersive transport
 - Urbach tail (band tail absorption)
 - Valence band structure in XPS
- the band tails are asymmetric
- in good material (PE-CVD grown):
 - VB tail slope 50 meV
 - CB tail slope 30 meV

Drift mobility in IGZO



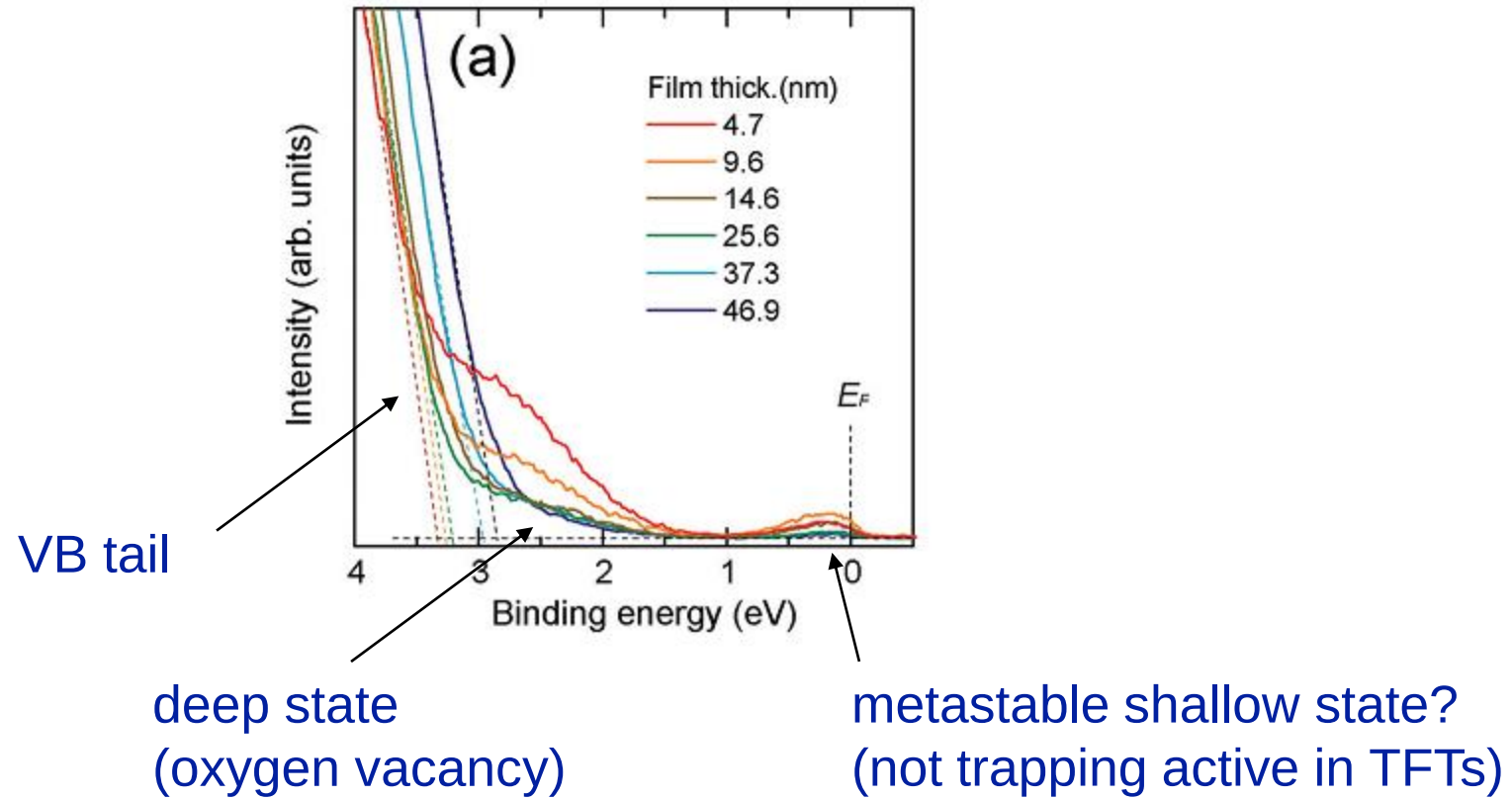
RT:
CB transport w.
trapping

LT:
hopping transport
w. trap distribution

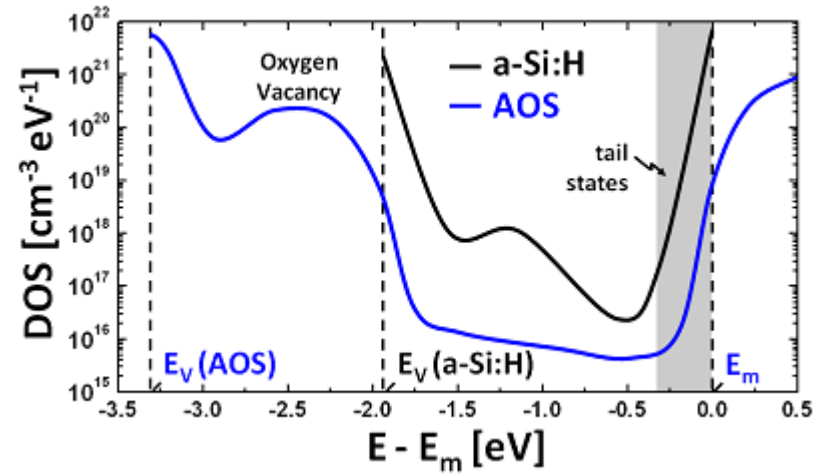


Dependence on bias voltage
(related to faster sweep over
trap sites, similar to a-Si:H)

XPS analysis of VB structure in IGZO



Emerging picture



Similar transport processes (trapping into tail states)
 IGZO: steeper CB tail, lower values for N_V and N_C

XPS suggests deep states